

Notice of References Cited	Application/Control No. 10/804,722		Applicant(s)/Patent Under Reexamination CHOI ET AL.	
	Examiner Jason M. Mandeville		Art Unit 2629	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2004/0113875	06-2004	Miller et al.	345/082
*	B	US-2001/0050532	12-2001	Eida et al.	313/504
*	C	US-6,475,845	11-2002	Kimura, Hajime	438/200
*	D	US-2004/0195963	10-2004	Choi et al.	313/504
*	E	US-7,012,588	03-2006	Siwinski, Michael J.	345/83
*	F	US-6,919,681	07-2005	Cok et al.	313/500
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.